

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chishio KOSHIMIZU et al.) Group Art Unit: 1763
Application No.: 10/675,966)) Examiner: KACKAR, RAM N
Filed: October 2, 2003))
For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD) Confirmation No. 6290)
Commissioner for Patents	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the final Office Action mailed July 12, 2006, the period for response having been extended to January 12, 2007 by a Petition for Extension of Time - Three Months and fee payment filed concurrently herewith, the period for response having been further extended by a Request for Continued Examination, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.